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ISSUE CLASSIFICATION	
Class	Subclass

PATENT NUMBER

U.S. UTILITY Patent Application

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 SCANNED 1552 Q.A. Am

PATENT DATE

APPLICATION NO. 09/843783	CONT/PRIOR	CLASS 438	SUBCLASS	ART UNIT 2812	EXAMINER J. OMAN
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APPLICANTS

Basant Jagannathan
Jack Chu
Ryan Wuthrich
Byeongju Park

TITLE

Method to increase carbon and boron doping concentrations in Si and SiGe films

PTO-2040
12/89

ISSUING CLASSIFICATION

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)		NOTICE OF ALLOWANCE MAILED	
	_____ _____ <			

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